

PTO-1449		Application No. 09/746,393		Applicant(s) John E. Schier	
Information Disclosure Citation in an Application		Docket Number 062891.0491		Group Art Unit 2135	
				Filing Date December 21, 2000	

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**U.S. PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	6,768,797 B2	07/27/04	Rose	380	247	05/09/03
B	6,779,111 B1	08/17/04	Gehrmann et al.	713	171	05/10/99
C	6,782,102 B2	08/24/04	Blanchard et al.	380	270	12/21/00
D	6,791,472 B1	09/14/04	Hoffberg	340	905	06/19/01
E	6,792,112 B1	09/14/04	Campbell et al.	380	270	03/17/00
F						
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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EXAMINER <i>Ly V. Hwa</i>	DATE CONSIDERED <i>4/21/04</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.